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## BIB DATA SHEET

CONFIRMATION NO. 8155

<b>SERIAL NUMBER</b> 10/809,704	<b>FILING or 371(c) DATE</b> 03/26/2004 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 1796	<b>ATTORNEY DOCKET NO.</b> 251148US0		
<b>APPLICANTS</b> Yuko Uchimar, Tsukuba-shi, JAPAN; Masami Inoue, Tokyo, JAPAN; <b>** CONTINUING DATA *****</b> <b>** FOREIGN APPLICATIONS *****</b> <span style="border: 1px solid black; padding: 0 5px;">MZ</span> JAPAN 2003-315923 09/08/2003 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 06/10/2004						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/MARC S ZIMMER/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 27	<b>TOTAL CLAIMS</b> 4	<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> OBLON, SPIVAK, MCCLELLAND MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA, VA 22314 UNITED STATES						
<b>TITLE</b> Low dielectric constant insulating material and semiconductor device using the material						
<b>FILING FEE RECEIVED</b> 2330	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees			
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